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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		Application Number	10/751,056
(use as many sheets as necessary)		Filing Date	January 2, 2004
		First Named Inventor	Gerianne Tringall
		Group Art Unit	1617
		Examiner Name	Jennifer M. Kim
Sheet	1	of	1
		Attorney Docket Number	FEM 104

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

Examiner's Signature	/Jennifer M Kim/	Date Considered	4/24/2009
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